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ACKNOWLEDGMENTS

INTERNATIONAL ROADMAP COMMITTEE

- ◆ *Europe*—Patrick Coge, Mart Graef, Bert Huizing, Reinhard Mahnkopf
- ◆ *Japan*—Hidemi Ishiuchi, Junji Shindo
- ◆ *Korea*—Siyong Choi, JaeSung Roh,
- ◆ *Taiwan*—Carlos H. Diaz, Burn Lin
- ◆ *U.S.A.*—Bob Doering, Paolo Gargini, Ian Steff

TECHNOLOGY WORKING GROUP KEY CONTRIBUTORS

2011 Cross TWG Study Group (Technology Pacing)—Alan Allan, Sitaram Arkalgud, Dave Armstrong, Joel Barnett, Roger Barth, Herb Bennett, Bill Bottoms, Juan-antonio Carballo, Chris Case, David Chan, Bill Chen, Alain Diebold, Bob Doering, Denny Fandel, Paul Feeney, Mike Gaitan, Mike Garner, Christina Hacker, Dan Herr, Jim Hutchby, Hirofumi Inoue, Raj Jammy, Scott Jones/ICKnowledge, Andrew Kahng, Leo Kenny, Larry Larson, Marcus Lentz, Mike Lercel, Rich Liu, Jurgen Lorenz, Ichiro Matsuo, Andreas Neuber, Kwok Ng, Andreas Nutsch, Dilip Patel, Jack Pekarik, Lothar Pfitzner, Gopal Rao, Mike Rodgers, Thomas Skotnicki, Hitoshi Wakabayashi, Linda Wilson, Osamu [Sam] Yamazaki, Victor Zhirnov, Paul Zimmerman

2011 Cross TWG Study Group (More than Moore)—Herbert Bennett, Bill Bottoms, Michel Brillouët, Juan-Antonio Carballo, Patrick Coge, Michael Gaitan, Mart Graef, Bert Huizing, Andrew Kahng, Reinhard Mahnkopf, Jack Pekarik

System Drivers and Design—Yoshimi Asada, Kenji Asai, Valeria Bertacco, Colin Bill, Ralf Brederlow, Yu Cao, Juan-Antonio Carballo, John Darringer, Wolfgang Ecker, Dale Edwards, Eric Flamand, Paul Franzone, Tamotsu Hiwatashi, Masaharu Imai, Kwangok Jeong, Bill Joyner, Andrew Kahng, Masaru Kakimoto, Jong Ho Kang, Victor Kravets, Frederic Lalanne, Jingwei Lu, Vinod Malhotra, Masami Matsuzaki, Alfonso Maurelli, Nikil Mehta, Katsutoshi Nakayama, Sani Nassif, Nobuto Ono, Ralf Pferdmenges, Shishpal Rawat, Wolfgang Rosenstiel, Toshitada Saito, Jean-Pierre Schoellkopf, Gary Smith, Peter Van Staa, Leon Stok, Mikio Sumitani, Masahisa Tashiro, Hiroki Tomoshige, Tadao Toyoda, Shireesh Verma, Maarten Vertregt, Alfred Wong, David Yeh, Hak-soo Yu

Test and Test Equipment—Andrew Aagaard, Debora Ahlgren, Rob Aitken, Ken-ichi Anzou, Dave Armstrong, Roberta Bailey Roberts, Roger Barth, John Bearden, Brady Benware, Sounil Biswas, Shawn Blanton, Ken Butler, Yi Cai, Wendy Chen, Calvin Cheung, Khushru Chhor, Steve Comen, Dennis Conti, Zoe Conroy, Peter Crabbe, Robert Daasch, Ted Eaton, Stefan Eichenberger, Bill Eklow, Francois-Fabien Ferhani, Shawn Fetterolf, Anne Gattiker, Rama Gudavalli, Kazumi Hatayama, Hirokazu Hirayama, Jeong Ho Cho, Hisao Horibe, Hiroki Ikeda, Shoji Iwasaki, Hongshin Jun, Rohit Kapur, Masahiro Kanase, Brion Keller, Takuya Kobayashi, Gibum Koo, Greg Labonte, Ken Lanier, Lenny Leon, Rien Looijen, Michio Maekawa, Amit Majumdar, Nilajan Mukherjee, Prasad Mantri, Peter Maxwell, Anne Meixner, Peter Muhmentahler, Taku Murakami, Takeshi Nagasaka, Masaaki Namba, Phil Nigh, Akitoshi Nishimura, Hermann Obermeier, Peter O'Neill, Jeyoung Park, Mike Peng Li, Frank Poehl, Chris Portelli-Hale, Bill Price, Joe Reynick, Brad Robbins, Paul Roddy, Mike Rodgers, Yasuo Sato, Taylor Scanlon, Rene Segers, Steven Slupsky, Satoru Takeda, Ken Taoka, Steve Tilden, Hirofumi Tsuboshita, Kees Visser, Jody Van Horn, Erik Volkerink, Adam Wright, Yervant Zorian

Process Integration, Devices, and Structures—Yasushi Akasaka, Dimitri Antoniadis, Gennadi Bersuker, Azeez Bhavnagarwala, Frederic Boeuf, Joe Brewer, Alex Burenkov, Seon Yong Cha, ChongPing Chang, Kin (Charles) Cheung, Ted Dellin, Kristin DeMeyer, Carlos Diaz, Bill Gallagher, Yasushi Gohou, Christopher Henderson, Toshiro Hiramoto, Digh Hisamoto, Atsushi Hori, Hsing-Hui Hsu, Jim Hutchby, Jiro Ida, Hirofumi Inoue, Kunihiro Iwamoto, Moon-Young Jeong, Gyoyoung Jin, Malgorzata Jurczak, Naoki Kasai, Shrikanth Krishnan, Fred Kuper, Hajime Kurata, Chung Lam, Robert Lander, Rich Liu, Witek Maszara, Ichiro Matsuo, Tohru Mogami, Kwok Ng, Tak Ning, Masaaki Niwa, Tony Oates, Hidekazu Oda, Jongwoo Park, Thierry Poiroux, Kirk Prall, Thomas Schulz, Kentaro Shibahara, James Stathis, Toshihiro Sugii, Shinichi Takagi, Kaneyoshi Takeshita, Tetsu Tanaka, Cheng-tzung Tsai, Wilman Tsai, Hitoshi Wakabayashi, Philip Wong, Yanzhong Xu, Geoffrey Yeap, Makoro Yoshimi, Scott Yu, Peter Zeitzoff

Radio Frequency and Analog/Mixed-signal Technologies—Jack Pekarik, Herbert Bennett, Carsten Ahrens, Kamel Benaissa, Bobby Brar, Pascal Chevalier, David Chow, Steve Cosentino, Julio Costa, Mattias Dahlstrom, Emerson Fang, Natalie Feilchenfeld, Toshiro Futatsugi, Brian Gerson, Evgeni Gousev, Yoshihiro Hayashi, Digh Hisamoto, Anthony Immorlica Jr., Snezana Jenei, Jay John, Alex Kalnitsky, Tom Kazior, Taffy Kingscott, Ginkou Ma, Jan-Erik Mueller, Wibo van Noort, Hansu Oh, Tatsuya Ohguro, Douglas Pattullo, Ed Preisler, Jean-Olivier Plouchart, Sam Shichijo, Kaneyoshi Takeshita, Sorin Voinigescu, Albert Wang, Dawn Wang, Geoffrey Yeap, David Yeh, Ian Young, Peter Zampardi, Jiangkai Zuo

Microelectromechanical Systems (MEMS)—Chris Apanius, Raji Baskaran, Herbert Bennett, Shawn Blanton, Raffaella Borzi, Bill Bottoms, Steve Breit, Michel Brillouet, Scott Bryant, Kevin Chau, Wendy Chen, Edward Chiu, Asif Chowdhury, Mark Crockett, Robert De Nuccio, Ingrid De Wolf, Don DeVoe, Stephane Donnay, Wei-Leun Fang, Koji Fukumoto, Michael Gaitan, Brian Gerson, Steve Greathouse, Raj Gupta, Buzz Hardy, Dave Howard, Brian Jamieson, Snezana Jenei, Rakesh Kumar, Ron Lawes, Chengkuo Lee, Karen Lightman, Jianmin Miao, Takashi Mihara, Veljko Milanovic, Josh Molho, Arthur Morris, Jim Mrvos, Yasutaka Nakashiba, Goro Nakatani, Fumihiko Nakazawa, Fabio Pasolini, Jack Pekarik, Dimitrios Peroulis, Gilles Poupon, Sacha Revel, Chuck Richardson, John Rychcik, Patric Salomon, Dominique Schinabeck, Jim Spall, Tony Stamper, Jae Sung Yoon, Monica Takacs, Tetsu Tanaka, Steve Tilden, Henne van Heeren, Chris van Hoof, Fabrice Verjus, Steve Walsh, Marcie Weinstein, Jurgen Wolf, Xiaoming Wu, Hiroshi Yamada

Emerging Research Devices—Hiro Akinaga, Tetsuya Asai, Yuji Awano, George Bourianoff, Michel Brillouet, John Carruthers, Ralph Cavin, Chorn-Ping Chang, An Chen, U-In Chung, Byung Jin Cho, Sung Woong Chung, Luigi Colombo, Shamik Das, Simon Deleonibus, Bob Doering, Tetsuo Endoh, Bob Fontana, Paul Franzon, Akira Fujiwara, Mike Garner, Dan Hammerstrom, Tsuyoshi Hasegawa, Shigenori Hayashi, Dan Herr, Mutsuo Hidaka, Toshiro Hiramoto, Jim Hutchby, Adrian Ionescu, Kiyoshi Kawabata, Seiichiro Kawamura, Suhwan Kim, Hyoungjoon Kim, Atsuhiko Kinoshita, Dae-Hong Ko, Hiroshi Kotaki, Franz Kreupl, Mark Kryder, Zoran Krivokapic, Kee-Won Kwon, Jong-Ho Lee, Lou Lome, Matthew Marinella, Hiroshi Mizuta, Kwok Ng, Dmitri Nikonov, Kei Noda, Ferdinand Peper, Yaw Obeng, Yutaka Ohno, Dave Roberts, Shintaro Sato, Barry Schechtman, Sadas Shankar, Kaushal Singh, Takahiro Shinada, Masayuki Shirane, Satoshi Sugahara, Shin-ichi Takagi, Ken Uchida, Thomas Vogelsang, Yasuo Wada, Rainer Waser, Jeff Welser, Frans Widershoven, Philip Wong, Dirk Wouters, Kojiro Yagami, David Yeh, In-Seok Yeo, Hiroaki Yoda, In-K Yoo, Victor Zhimov

Emerging Research Materials—Hiro Akinaga, Jesus de Alamo, Dimitri Antoniadis, Nobuo Aoi, Masakazu Aono, Koyu Asai, Asen Asenov, Yuji Awano, David Awschalom, Rama Ayothi, Kaustav Banerjee, Chris Bencher, Agnès Barthélémy, Daniel-Camille Bensahel, Kris Bertness, Stacey Bent, Mikael Björk, August Bosse, Bill Bottoms, George Bourianoff, Rod Bowman, Alex Bratkovski, Robert Bristol, Ahmed Busnaina, Jeff Calvert, John Carruthers, Bernie Capraro, Chris Case, David Chan, An Chen, Eugene Chen, Zhihong Chen, Joy, Cheng, Toyohiro Chikyow, Byung Jin Cho, U-In Chung, Jonathan Coleman, Luigi Colombo, Johann Coraux, Hongjie Dai, Ralph Dammel, Juan DePablo, Anton Devilliers, Thibaut Devolder, B. Dieny, Jean Dijon, Athanasios Dimoulas, Catherine Dubourdieu, John Ekerdt, Tetsuo Endoh, James Engstrom, Thomas Ernst, Michael Flatte, Glenn Fredrickson, Gregory Fuchs, Satoshi Fujimura, C. Michael Garner, Emmanuel Giannelis, Niti Goel, Michael Goldstein, Suresh Golwalkar, Guido Groeseneken, Roel Gronheid, Wilfried Haensch, Cliff Henderson, Daniel Herr, Hiro Hibino, Marc Hillmyer, Bill Hinsberg, Toshiro Hiramoto, Judy Hoyt, Greg Hughes, Jim Hutchby, Harold Hwang, Hyunsang Hwang, K. Inoue, Takamasa Ishigaki, Saori Ishizu, Nobuyuki Ishiwata, Yoshio Ishiwata, Kohei Ito, Taisuke Iwai, Ajey Jacob, Raj Jami, David Jamieson, Ali Javey, James Jewett, Berry Jonker, Xavier Joyeux, Yeon Sik Jung, Ted Kamins, Zia Karim, Takashi Kariya, Takashi Kariya, Masashi Kawaski, Leo Kenny, Richard Klein, Philip Kim, Sang Ouk Kim, Michael Kozicki, Mark Kryder, Roger Lake, Steve Lange, Sean King, Atsuhiko Kinoshita, Gabriel Kotliar, Victor Krivokapic, Mark Kryder, Yi-Sha Ku, Hiroshi Kumigashira, Nabil Laachi, Jang Ein Lee, Yi Jun Lee, Harry Levinson, Chenhsin Lien, Liew Yun Fook, Lloyd Litt, Scott List, Chi Chun Liu, Wei-Chung Lo, Louis Lome, Gerry Lucovsky, Mark Lundstrom, Yale Ma, Allan MacDonald, Blanka Magyari-Kope, Prashant Majhi, Arun Majumdar, Francois Martin, Lane Martin, Witek Maszara, Jennifer McKenna, Fumihiko Matsukura, Nobuyuki Matsuzawa, Claudia Mewes, Dan Millward, Yoshiyuki Miyamoto, Stephane Monfray, Andrea Morello, Mick Morris, Azad Naemi, Boris Naydenov, C Gomez-Navarro, Paul Nealey, Kwok Ng, Fumiyuki Nihey, Mizuhisa Nihey, Yoshio Nishi, Kei Noda, Yaw Obeng, Chris Ober, Katsumi Ohmori, Yutaka Ohno, Laurent Pain, Ray Pearson, Jeff Peterson, Er-Xuan Ping, Alexei Preobrajenski, Victor Pushparaj, Ganapati Ramanath, Ramamoorthy Ramesh, Nachiket Raravikar, Ben Rathsack, Curt Richter, Heike Riel, Dave Roberts, Sven Rogge, Jae Sung Roh, Ricardo Ruiz, Thomas Russell, Tadashi Sakai,

Gurtej Sandhu, Krishna Saraswat, Hideyuki Sasaki, Mitusru Sato, Shintaro Sato, Barry Schechtman, Thomas Schenkel, Jan Seidel, Mizuki Sekiya, Sadasivan Shankar, Matthew Shaw, Takahiro Shinada, Michelle Simmons, K. Singer, Kaushal K. Singh, Jon Slaughter, Mark Slezak, Bruce Smith, Tom Smith, Mark Somervell, Mark Stiles, Tsung-Tsan Su, Maki Suemitsu, Naoyuki Sugiyama, Chun-Yung Sung, Raja Swaminathan, Michiharu Tabe, Hidenori Takagi, Shin-ichi Takagi, Koki Tamura, Shinji Tarutani, Raluca Tiron, Yoshihiro Todokoro, Yasuhide Tomioka, Peter Trefonas, Ming-Jinn Tsai, Wilman Tsai, Vincent Tung, King Tu, Mark Tuominen, Ken Uchida, Marc Ulrich, Philippe Vereecken, Yasuo Wada, Vijay Wakharkar, Kang Wang, Weie Wang, Zhong Lin Wang, Rainer Waser, Jeff Welser, Lars-Erik Wernersson, Andrew Whittaker, Grant Willson, C.P. Wong, H.S. Philip Wong, Dirk Wouters, Wen-Li Wu, Hiroshi Yamaguchi, Toru Yamaguchi, Chin-Tien Yang, Kenji Yoshimoto, Yi-Sha Yu, SC Zhang, Yuegang Zhang, Jiro Yugami, Victor Zhirnov, Paul Zimmerman, Chuck Zmanda

Front End Processes—Mauro Alessandri, Luis Aparicio, Aksey Sehgal, Souvik Banerjee, Joel Barnett, Twan Bearda, Meridith Beebe, Steve Benner, Ivan (Skip) Berry, Chris Borst, John Boyd; Ian Brown, Arifin Budihardio, Murray Bullis, Mayank T. Bulsara, Jeff Butterbaugh, George K. Celler, Luke Chang, Victor Chia, Phil Clark, Lee Cook, Jeffrey Cross, Adrien Danel, Suman Datta, Carlos H. Diaz, Roxanne Dulas, Paul Feeney, Graham Fisher, Mike Fury, Glenn Gale, Yehiel Gotkis, Mike Goldstein, Christina Gottschalk, Aomar Halimaoui, Qingyuan Han, Dick Hockett, Andrew Hoff, Yoshimasa Horii, Greg Hughes, William Hughes, Dick James; Raj Jammy, Andreas Kadavanich, Ravi Kanjolia, Bruce Kellerman, Deoksin Kil, Hyungsup Kim, Simon Kirk, Brian Kirkpatrick, Hiroshi Kitajima, Martin Knotter, Daniel Koos, Hwasung Kyunggi-Do, Larry Larson, Jeff Lauerhaas, Yannick Le Tiec, Kuntack Lee, Jooh Yun Lee, Tom Lii, Hong Lin, Prashant Majhi, Tom McKenna, Kevin McLaughlin, Paul Mertens, Katsuhiko Miki, Ichiro Mizushima, Mansour Monipour, Paul Morgan, Brian Murphy, Anthony Muscat, Sadao Nakajima, Yasuo Nara, Masaaki Niwa, Toshihide Ohgata, Hiroshi Oji, Jin-Goo Park, Friedrich Passek, Eric Persson, Darryl Peters, Gerd Pfeiffer, Jagdish Prasad, Srini Raghavan, Maud Rao, Rick Reidy, Karen Reinhardt, Hwa-sung Rhee, Rob Rhoades, Marcello Riva, Jae-Sung Roh, Akira Sakai, Archita Sengupta, YugYun Shin, James Shen, Wolfgang Sievert, Chris Sparks, Robert Standley, Sing-Pin Tay, Bob Turkot, Allan Upham, Steven Verhaverbeke, Rita Voss, Hitoshi Wakabayashi, Mike Walden, Masaharu Watanabe, Han Xu

Lithography—Miyake Akira, Chris Bencher, Markus Bender, David Chan, Yao Ching Ku, Will Conley, Nigel Farrar, Ted Fedynyshyn, Heiko Feldmann, Emily Gallagher, Reiner Garreis, Cesar Garza, Bob Gleason, Frank Goodwin, Roel Gronheid, Naoya Hayashi, Dan Herr, Iwao Higashikawa, George KC Huang, Greg Hughes, Sean Huh, Yoshiaki Ikuta, Rik Jonckheere, David Kyser, Michael Lercel, Harry Levinson, Ted Liang, Changmoon Lim, Lloyd Litt, Pawitter Mangat, Greg McIntye, Toshio Nakajima, Patrick Naulleau, Hirayanagi Noriyuki, Masahiko Okumura, Kazuya Ota, Eric Panning, Moshe Preil, Abbas Rastegar, Doug Resnick, Bryan Rice, Morty Rothschild, Tsutomu Shoki, Keith Standiford, Seong Sue Kim, Serge Tedesco, Tsuneo Terasawa, Walt Trybula, Takayuki Uchiyama, Mauro Vasconi, Phil Ware, John Wiesner, Grant Willson, Obert Wood, Stefan Wurm, Tetsuo Yamaguchi, Tony Yen, John Zimmerman

Interconnect—Nobuo Aoi, Sitaram Arkalgud, Lucile Arnaud, Koji Ban, Hans-Joachim Barth, Eric Beyne, Boyan Boyanov, Christopher Case, Chung-Liang Chang, Hsien-Wei Chen, Wen-Chih Chiou, Gilheyun Choi, Jinn-P. Chu, Mike Corbett, Alexis Farcy, Paul Feeney, Takashi Hayakawa, Cheng-Chieh Hsieh, Masayoshi Imai, Atsunobu Isobayashi, Raymond Jao, Shin-Puu Jeng, Ajey Joshi, Morihiro Kada, Sibum Kim, Nobuyoshi Kobayashi, Mauro Kobrinsky, Kaushik Kumar, Nohjung Kwak, Hyeon Deok Lee, Scott List, Anderson Liu, Didier Louis, Toshiro Maekawa, David Maloney, Akira Matsumoto, Azad Naeemi, Mehul Naik, Tomoji Nakamura, Yuichi Nakao, Akira Ouchi, Roger Quon, Rick Reidy, Scott Pozder, Larry Smith, Mark Scannell, Hideki Shibata, Michele Stucchi, Weng Hong Teh, Zsolt Tokei, Thomas Toms, Manabu Tsujimura, Kazuyoshi Ueno, Osamu Yamazaki, Paul Zimmerman

Factory Integration—Daniel Babbs, Al Chasey, Gino Crispieri, Peter Csatory, Mike Czerniak, Dave Eggleston, Dave Eggleston, Terry Francis, Mike Garner, Astrid Gettel, Parris Hawkins, Silke Hermanns, Dan Herr, Scott Jones, Akira Kashimoto, Leo Kenny, Shige Kobayashi, Les Marshall, Kristy McDonald, Reiner Missale, Mike Mocella, Julian Montoya, James Moyne, Andreas Neuber, Richard Oechsner, Gopal Rao, Daniel Stevens

Assembly and Packaging—Sai Ankireddi, Bernd Appelt, Thomas Baer, Muhannad S. Bakir, Aouvik Banarjee, Hans-Joachim Barth, Rozalia Beica, Steve Bezuk, W. R. Bottoms, Bill Burdick, Yi-jen Chan, Carl Chen, William Chen, Sonjin Cho, Yulkyo Chung, Bob Chylak, Horst Clauberg, Mark De Samber, Krishor Desai, Dan Evans, Bradford Factor, Tatsuhiro Fujiki, Michel Garnier, Steve Greathouse, Tom Gregorich, Richard Grzybowski, George Harman, Tomoo Hayashi, Willem Hoving, Mike Hung, John Hunt, T. S. Hwang, Taejoo Hwang, Kazuyuki Imamura, Dan Kilper, Mitchitaka Kimura, Shoji Kitamura, Tzu-Kun Ku, Choon Heung Lee, Ricky S W Lee, Rong-Shen Lee, Woong Sun Lee., Russell Lewis, Sebastian Liau, Weichung Lo, Debendra Mallik, Kaneto Matsushita, Lei Mercado, Stan Mihelcic,

David Miller, Hirofumi Nakajima, Keith Newman, Gary Nicholls, Grace Omalley, John Osenbach, Richard F. Otte, Bob Pfahl, Gilles Poupon, Klaus Pressel, Gamal Refai-Ahmed, Charles Reynolds, Charles Richardson, Philippe Robert, Peter Robinson, Bernd Roemer, Gurtej Sandu, Naoto Sasaki, Shahriar Shahramian, Paul Sibling, Vern Solberg, Kaoru Sonobe, Simon Stacey, Yoshiaki Sugizaki, Teresa Sze, Coen Tak, Patrick Thompson, Patrick Thompson, Claudio Truzzi, Andy Tseng, Shoji Uegaki, Henry Utsunomiya, Kripesh Vaidyanathan, Freek Van Straten, Julien Vittu, James Wilcox, Max Juergen Wolf, Jie Xue, Hiroyoshi Yoshida

Environment, Safety, and Health—Hans-Peter Bipp, Reed Content, Dan Herr, Terry Francis, Mike Garner, Tim Higgs, Francesca Illuzzi, Jim Jewett, Leo Kenny, Michael Mocella, Andreas Neuber, Walter Worth

Yield Enhancement—Mutsuhiro Amari, Scott Anderson, Dwight Beal, David Blackford, Marc Camenzind, Jan Cavelaars, Jeff Chapman, Wai-Ming Choi, Hubert Chu, Robert Clark, John DeGenova, Charley Dobson, Arnaud Favre, Giuseppe Fazio, Francois Finck, Dan Fuchs, Takashi Futatsuki, Guillaume Gallet, Delphine Gerin, Astrid Gettel, Rick Godec, Milton Goldwin, Barry Gotlinsky, Cherguo Guo, Mathias Haeuser, Asad Haider, Jeff Hanson, Teruyuki Hayashi, Christoph Hocke, YCHuang Huang, Masahiko Ikeno, Francesca Illuzzi, Hans Jansen, Jost Kames, Gene Karwacki, Barry Kennedy, Keith Kerwin, Suhas Ketkar, Y.J. Kim, Katsunobu Kitami, Kaoru Kondoh, Naoki Kotani, John Kurowski, Sumio Kuwabara, Bob Latimer, Ravi Laxman, Victor Liang, Slava Libman, Rushikesh Matkar, Yasuhiko Matsumoto, Tim Miller, Fumio Mizuno, William Moore, Chris Muller, Hiroshi Nagaishi, Andreas Neuber, Kazuo Nishihagi, Andreas Nutsch, Kevin Pate, Dilip Patel, Ruben Pessina, Lothar Pfitzner, Larry Rabellino, Dieter Rathei, Rich Riley, David Roberts, Biswanath Roy, Koichiro Saga, Hideyuki Sakaizawa, Tony Schleisman, Yoshimi Shiramizu, Drew Sinha, Terry Stange, Isamu Sugiyama, Yoshitaka Tatsumoto, Ines Thurner, Hiroshi Tomita, Takahiro Tsuchiya, Ken Tsugane, Dan Wilcox, Hubert Winzig, Ray Yang, Mao-Hsiang Yen

Metrology—Carlos Beitia, Ben Bunday, Alain Diebold, Brendan Foran, Christina Hacker, Karey Holland, Masahiko Ikeno, Eiichi Kawamura, Adrian Kiermasz, Delphine Le Cunff, Scott List, Philippe Maillot, Yaw Obeng, George Orji, Brennan Peterson, Dave Seiler, Chin Soobok, Vic Vartanian, Andras Vladar, Yuichiro Yamazaki

Modeling and Simulation— Nobutoshi Aoki, Jean-Charles Barbe, Francis Benistant, Augusto Benvenuti, Gilles Le Carval, Jaehoon Choi, Mauro Ciappa, Derren Dunn, Andreas Erdmann, Roman Gafiteanu, Wladek Grabinski, Tibor Grasser, An De Keersgieter, Wolfgang Demmerle, Ronald Gull, Bert Huizing, Herve Jaouen, Serkan Kincal, Wilfried Lerch, Jürgen Lorenz, Wolfgang Molzer, Victor Moroz, Chandra Mouli, Aneesh Nainani, Yon-Sup Pang, Hwasik Park, Jin-Kyu Park, Peter Pichler, Shigeo Satoh, Yi-Ming Sheu, Vivek Singh, I.C. Yang

REGIONAL SUPPORT TEAMS

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◆ *Europe*—Tosca Danneck, Monika Kemtari

◆ *Japan*—Mina Sekiguchi

◆ *Korea*—BaeKeun Jun, Jae-Min Jun, In-Hee Jung, J.W. Ko

◆ *Taiwan*—Celia Shih

◆ *USA*—Yumiko Takamori, Linda Wilson; *Intel meeting support team*—Barbara Pebworth;

SEMATECH—Jessica Pugliese; *SEMI*— Judy Ajifu, Agnes Cobar; *SIA*—Devi Bengfort

